



**ELECTRONIC COPY**

LG794608870  
Report verification at igi.org



May 5, 2026

IGI Report Number **LG794608870**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **CUT CORNERED  
RECTANGULAR MODIFIED  
BRILLIANT**

Measurements **8.64 X 6.27 X 4.28 MM**

**GRADING RESULTS**

Carat Weight **2.04 CARATS**

Color Grade **E**

Clarity Grade **VVS 1**

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Carat Weight **2.04 CARATS**

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Clarity Grade **VVS 1**

**ADDITIONAL GRADING INFORMATION**

Polish **VERY GOOD**

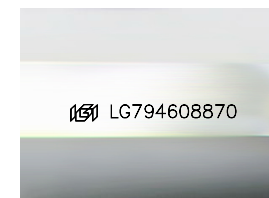
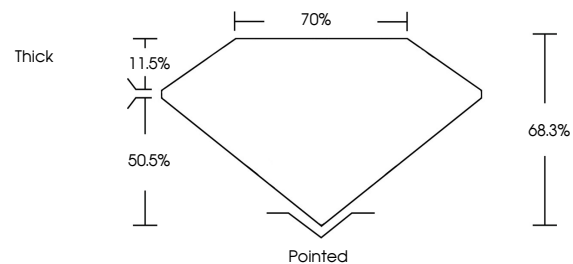
Symmetry **VERY GOOD**

Fluorescence **NONE**

Inscription(s) **IGI LG794608870**

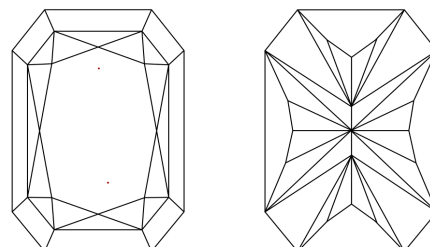
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

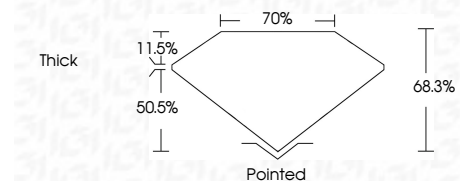
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



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IGI Report No LG794608870  
CUT CORNERED RECT. MODIFIED BRILLIANT  
8.64 X 6.27 X 4.28 MM  
2.04 CARATS  
E  
VVS 1  
68.3%  
70%  
Thick  
Pointed  
Polish  
VERY GOOD  
Symmetry  
VERY GOOD  
Fluorescence  
NONE  
Inscription(s)  
IGI LG794608870

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Type IIa